

| Search Notes  | Application/Control No. | Applicant(s)/Patent under Reexamination |
|--|-------------------------|---|
| | 09/997,647 | CHANG, CHIN-LIN |
| Examiner | Art Unit | |
| Lisa M. Caputo | 2876 | |

| INTERFERENCE SEARCHED | | | |
|-----------------------|-----------|----------|----------|
| Class | Subclass | Date | Examiner |
| See | All Above | 2/4/2006 | LMC |
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